## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT:

Hiroki Kikuchi

ATTORNEY DOCKET NO:

09792909-5025

SERIAL NO.

GROUP ART UNIT:

FILING DATE:

**EXAMINER:** 

INVENTION:

"FOCUSING CONTROL MECHANISM, AND INSPECTION

APPARATUS USING SAME"

## **PRELIMINARY AMENDMENT**

Asst. Commissioner of Patents Washington, D.C. 20231

Sir:

Please add the following at page 1 between the title and the heading "Background of the Invention."

## -- RELATED APPLICATION DATA

The present application claims priority to Japanese Application No. P2000-155403 filed May 25, 2000 which application is incorporated herein by reference to the extent permitted by law.--

Respectfully submitted,

David R. Metzger

, Reg. 32,919

CONNENCCHENIA TA

SONNENSCHEIN NATH & ROSENTHAL

P.O. Box 061080

Wacker Drive Station Sears Tower

Telephone: 312/876-8000 Facsimile: 312/876-7934

Attorneys for Applicant